



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 21, 2025	
IGI Report Number	LG678533760
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE EMERALD CUT
Measurements	6.82 X 6.80 X 4.52 MM

GRADING RESULTS

Carat Weight	2.01 CARATS
Color Grade	FANCY INTENSE PINK
Clarity Grade	VVS 2

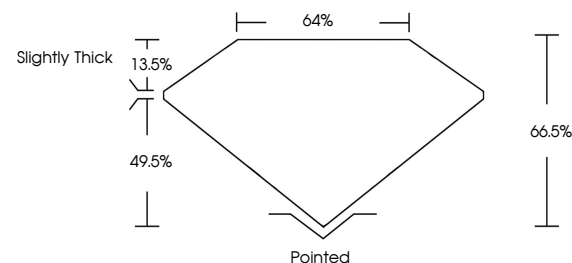
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	STRONG
Inscription(s)	131 LG678533760

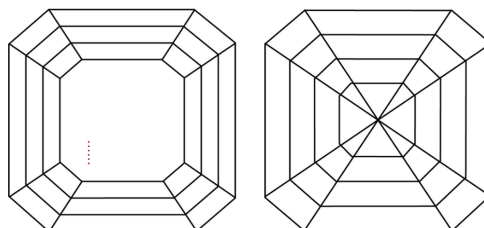
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Indications of post-growth treatment.

LG678533760
Report verification at igi.org

PROPORTIONS

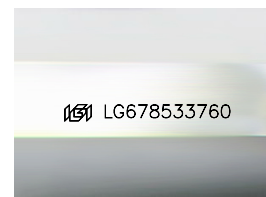


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

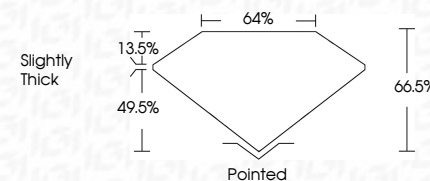
CLARITY

IF VWS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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(CVD) growth process.